

Electronic Acknowledgement Receipt

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Application Number:	10765361
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Title of Invention:	Method of depositing low k films
First Named Inventor:	Tzu-Fang Huang
Customer Number:	44257
Filer:	Keith M. Tackett/Tammi Thomas
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Notice of Appeal Filed	002592C8_APPEAL_EF.pdf	56955	no	1

Warnings:	
Information:	
Total Files Size (in bytes):	56955
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<p>National Stage of an International Application under 35 U.S.C. 371 If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p>	